



PATENT

Case Docket No. ASMINT.055AUS  
Date: January 16, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Timmermans et al.  
Appl. No. : 10/690,215  
Filed : October 20, 2003  
For : METHOD FOR THE  
DEPOSITION OF SILICON  
NITRIDE FILMS (As amended  
herewith)  
Examiner : Unknown  
Group Art Unit : Unknown

I hereby certify that this correspondence and all  
marked attachments are being deposited with the  
United States Postal Service as first class mail in  
an envelope addressed to: Commissioner for  
Patents, P.O. Box 1450, Alexandria, VA 22313-  
1450, on

January 20, 2004

(Date)

Adeel S. Akhtar, Reg. No. 41,394

TRANSMITTAL LETTER

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) Preliminary Amendment in 3 pages.
- (X) An Information Disclosure Statement in 1 page.
- (X) A PTO Form 1449 listing one (1) reference.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.

Adeel S. Akhtar  
Registration No. 41,394  
Attorney of Record  
Customer No. 20,995  
(415) 954-4114